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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL. NUM 10079519	FILING DATE 02/22/2002	CLASS 355	SUBCLASS S	GAU 2851	EXAMINER H. Nguyen
**APPLICANTS: Omura Yasuhiro;					
**CONTINUING DATA VERIFIED: <i>HN</i>					
** FOREIGN APPLICATIONS VERIFIED: JAPAN P2001-049306 02/23/2001 JAPAN P2001-254704 08/24/2001 <i>HN</i>					
PG-PUB <input type="checkbox"/>		DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>	
Foreign priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no		35 USC 119 conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO 1539.1019	
Verified and Acknowledged Examiners's initials <i>HN</i>					
TITLE : Projection optical system, projection exposure apparatus, and projection exposure method <small>U.S. DEPT. OF COMM./PAT. & TM-PTO-436L (Rev. 12-94)</small>					

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
Assistant Examiner			
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg. Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		Primary Examiner	
		Application Examiner	
		PREPARED FOR ISSUE	
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